
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Koemtzipoulos et al.

Attorney Docket No.:
LAM1P186/P1211

Application No.: 10/803,342

Examiner: Alanko, Anita K.

Filed: March 17, 2004

Group: 1792

Title: DUAL DOPED POLYSILICON AND
SILICON GERMANIUM ETCH

Confirmation: 5586

CERTIFICATE OF EFS-WEB TRANSMISSION

I hereby certify that this correspondence is being transmitted electronically through EFS-WEB to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on September 25, 2008.

Signed: _____/Dawn Wold/_____
Dawn Wold

AMENDMENT A

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated June 25, 2008 please amend the above-identified patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begin on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.